



PATENT
Attorney Docket No: AUB-06300

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:) Group Art Unit: 1762
Yonhua Tzeng) Examiner: Stouffer, Kelly M.
Serial No.: 10/772,740)
Filed: February 5, 2004) **AMENDMENT AND REQUEST FOR
For: **METHOD OF PLASMA**
ENHANCED CHEMICAL VAPOR
DEPOSITION OF DIAMOND
USING METHANOL-BASED
SOLUTIONS**)
Customer No.: 28960

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENTS

Sir:

Please amend the subject application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.

CERTIFICATE OF MAILING (37 CFR§ 1.8(a))
I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450

HAVERSTOCK & OWENS LLP.

Date: 5/11/07 Minerva Tellez